



Degradation analysis based on the Inverse Gaussian Process model

Songhua Hao

PhD. Candidate, Beihang University, Beijing, China

Visitor, Gipsa lab, Grenoble, France.

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The background features a large, light blue watermark of the Beihang University logo. The logo is circular and contains the university's name in Chinese characters '北京航空航天大学' at the top and 'BEIHANG UNIVERSITY' at the bottom. In the center of the logo is a stylized aircraft with a star above it, and the year '1952' is written below the aircraft.

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PART ONE

Research background

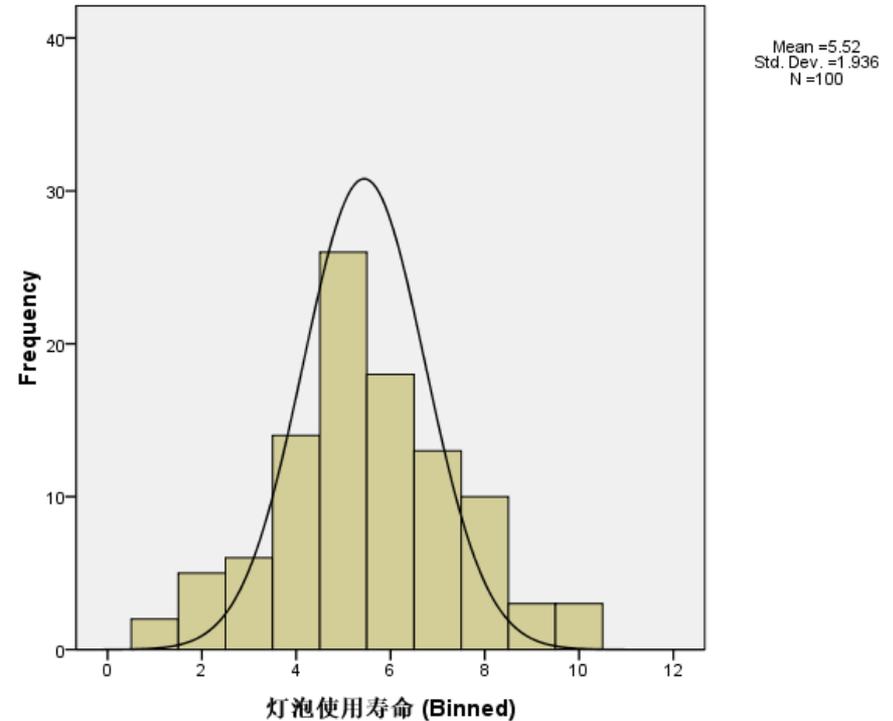
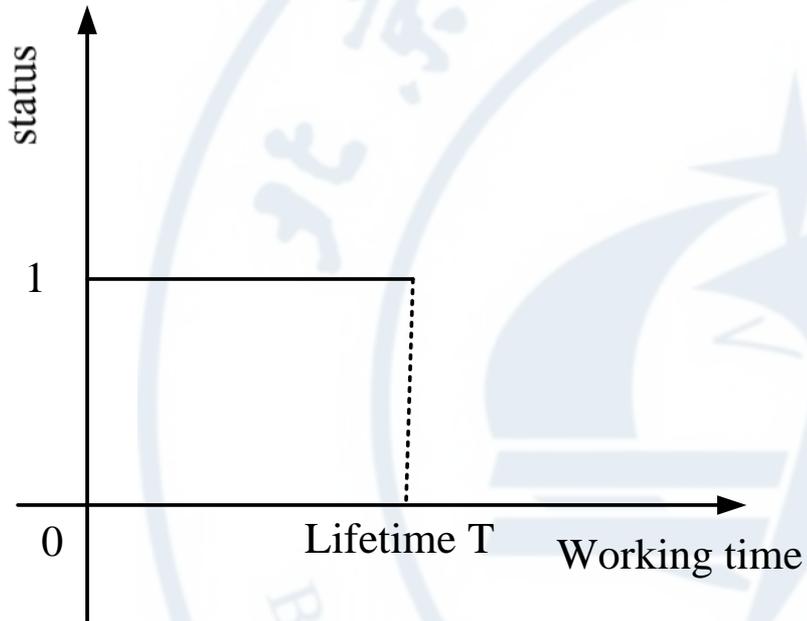
Reliability is defined as (ISO):

- The ability of an item to perform a required function, under given environmental and operating conditions and for a stated period of time.

Failure: the item loses this ability.

Reliability data analysis:

- Lifetime data;
- degradation measurement.



New challenges:

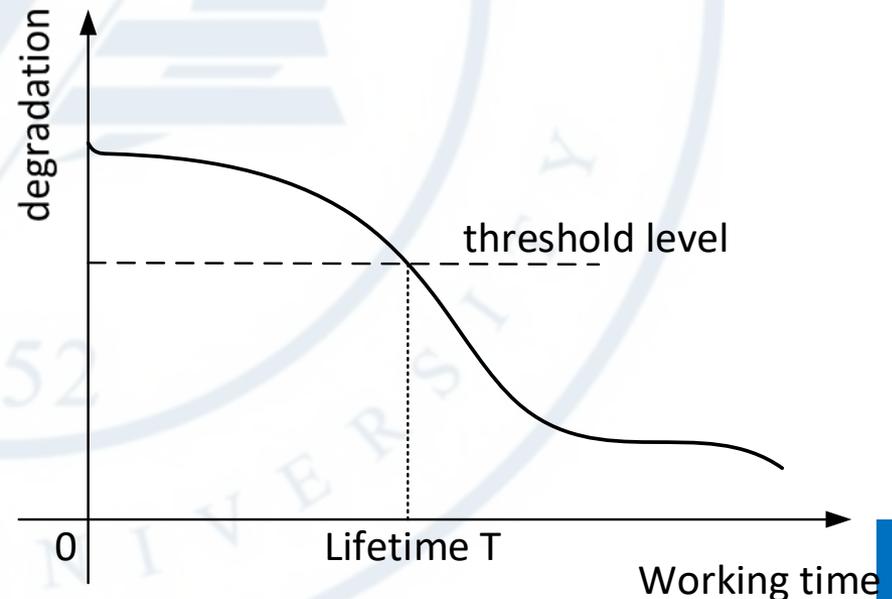
- High-reliability and long-life products
- Temporal variability and unit-to-unit variability
- Dynamic decision-making in maintenance

Reliability analysis based on

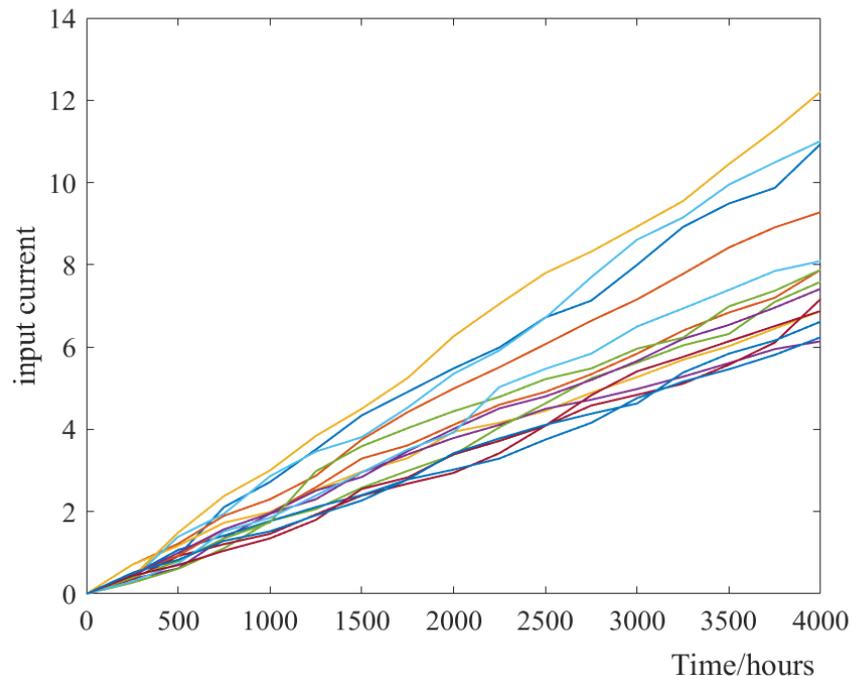
degradation data:

$$R(t) = P\{X(\tau) \notin \Omega, \forall 0 \leq \tau \leq t\}$$

$$T = \inf\{t : X(t) \in \Omega\}$$

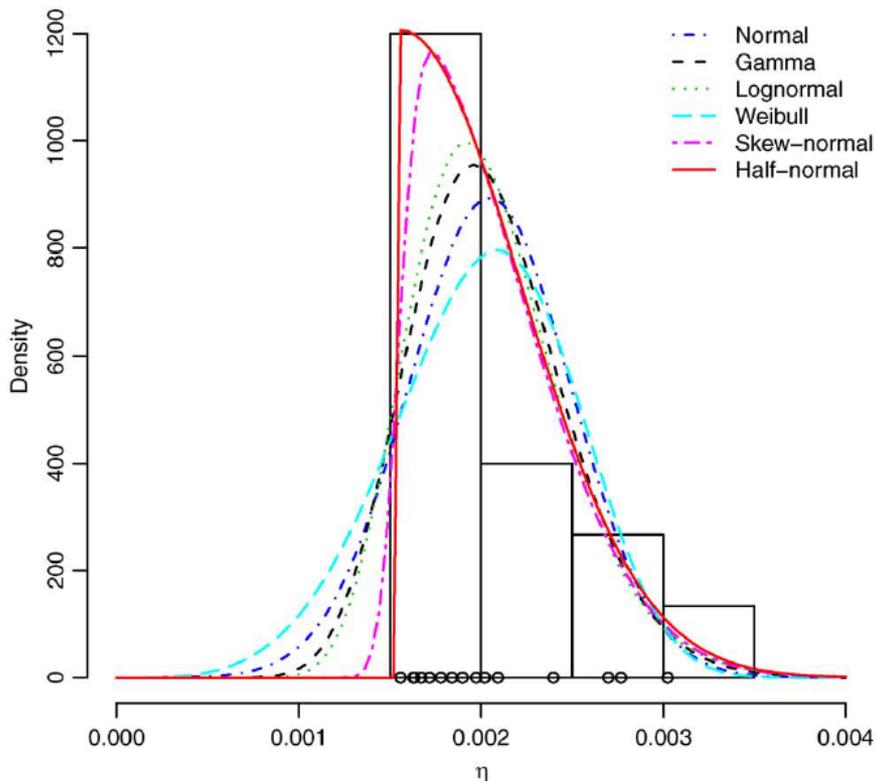


- Statistically **independent** degradation increments;
- $Y_0(t) - Y_0(s)$ follows an **IG distribution** $IG(\beta\Delta\Lambda(t), \eta\Delta\Lambda^2(t))$.
- ✓ better fitting results for the GaAs laser degradation.



□ Symmetric and normal random effects

$$X_0(t) - X_0(s) \sim IG(\beta\Delta\Lambda(t), \eta\Delta\Lambda^2(t)), \beta^{-1} \sim N(\mu, \sigma^2)$$



Distribution type	L	AIC
Normal	-89.8168	183.63
Gamma	-90.3049	184.61
Lognormal	-90.6636	185.33
Weibull	-89.1474	182.29
Skew-normal	-87.4892	178.98

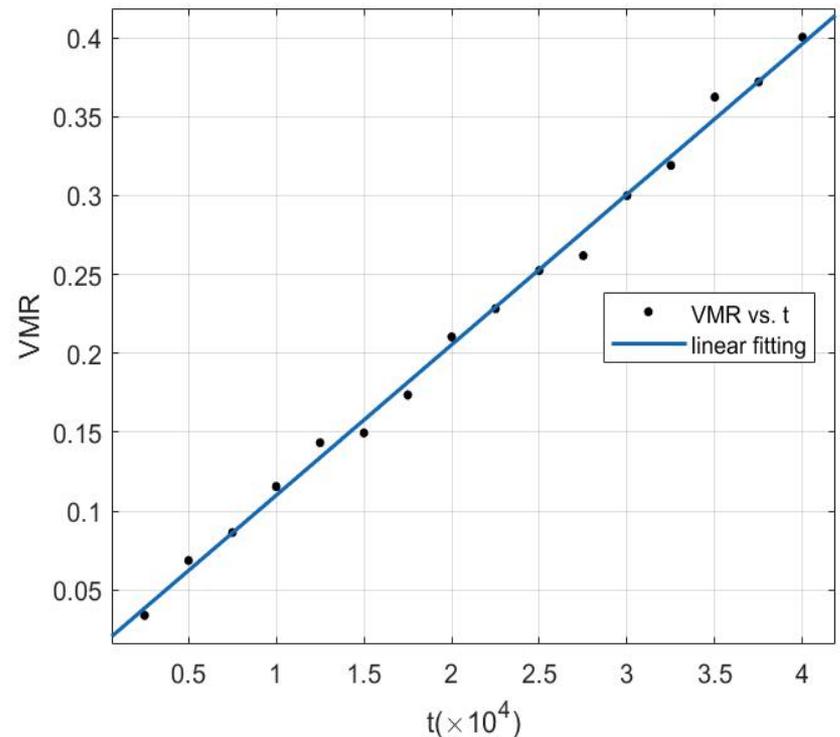
□ Constant variance-to-mean ratio (VMR)

For the **additivity** of the IG distributions $IG(\beta\Delta\Lambda(t), \eta\Delta\Lambda^2(t))$.

$$E[X(t)] = \beta\Lambda(t)$$

$$\text{Var}[X(t)] = \frac{[\beta\Lambda(t)]^3}{\eta\Lambda^2(t)} = \frac{\beta^3}{\eta}\Lambda(t)$$

$$\text{VMR}[X(t)] = \frac{\text{Var}[X(t)]}{E[X(t)]} = \frac{\beta^2}{\eta}$$





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PART TWO

Degradation modelling

- ① SN random effects
- ② time varying VMR

Degradation model $\{X_0(t), t \geq 0\}$:

- Statistically **independent** degradation increments;
- Degradation level $X_0(t)$ follows IG distribution:

$$F_{X_0}(x) = \Phi \left[\sqrt{\frac{\eta \Lambda^2(t)}{x}} \left(\frac{x}{\beta \Lambda(t)} - 1 \right) \right] + \exp \left\{ \frac{2\eta \Lambda(t)}{\beta} \right\} \Phi \left[-\sqrt{\frac{\eta \Lambda^2(t)}{x}} \left(\frac{x}{\beta \Lambda(t)} + 1 \right) \right]$$

- $\delta = \beta^{-1}$ follows **skew-normal distribution** $SN(\mu, \sigma^2, \alpha)$:

$$f_{\delta}(u) = \frac{2}{\sigma} \phi \left(\frac{u - \mu}{\sigma} \right) \Phi \left(\alpha \frac{u - \mu}{\sigma} \right)$$

Reliability assessment:

$$R(t) = P\{X(\tau) \notin \Omega, \forall 0 \leq \tau \leq t\}, T = \inf\{t: X(t) \in \Omega\}$$

Considering IG process is **monotonous**, its reliability can be simplified by:

$$F_{T_0}(t) = P\{X_0(t) > D\} = 1 - F_{X_0}(D)$$

If we consider **SN random effects**, lifetime CDF will be:

$$F_{T_2}(t) = \int_{-\infty}^{+\infty} F_{T_0}(t|u) f_{\delta}(u) du$$

$$= E_{\delta} \left[\Phi \left(-\sqrt{\frac{\eta \Lambda^2(t)}{x}} + \sqrt{\eta x} \delta \right) \right] + E_{\delta} \left[e^{2\eta \Lambda(t) \delta} \Phi \left(-\sqrt{\frac{\eta \Lambda^2(t)}{x}} - \sqrt{\eta x} \delta \right) \right]$$

Reliability assessment:

For $V \sim SN(\mu, \sigma^2, \alpha)$, the computations of $E_V[\Phi(A + BV)]$ and $E_V[e^{cV}\Phi(A + BV)]$:

$$(1) I(a_1, a_2, b_1, b_2) = \int_{-\infty}^{+\infty} \Phi(a_1 + b_1x)\Phi(a_2 + b_2x)\phi(x) dx;$$

(2) Based on Dominated Convergence Theorem, compute the **second order partial derivative** of $I(a_1, a_2, b_1, b_2)$ with respect to a_1, a_2 ;

(3) **Integrate** it over a_1, a_2 ;

(4) With some **changes of variables**, obtain the results.

Parameter estimation:

Test data: $x_{n,m} = x(t_{n,m})$ denotes the m^{th} degradation measurement of sample n ; $\Delta x_{n,m} = x_{n,m} - x_{n,m-1}$.

Log-Likelihood function: $L(x) = \sum_{n=1}^N \sum_{m=1}^M \ln f_{\Delta X}(\Delta x_{n,m})$

where

$$f_{\Delta X}(x) = \int_{-\infty}^{+\infty} f_{\Delta X_0}(x|\delta = \beta^{-1} = u) f_{\delta}(u) du$$

$$= E_{\delta} \left[\sqrt{\frac{\eta \Delta \Lambda^2(t)}{2\pi x^3}} \exp \left\{ -\frac{\eta}{2x} [x^2 \delta^2 - 2\Delta \Lambda(t)x\delta + \Delta \Lambda^2(t)] \right\} \right]$$

Maximize $L(x)$ and obtain the MLEs of $\Theta = \{\theta_{\Lambda}, \eta, \mu, \sigma, \alpha\}$.

a perturbed IG process model $\{Y(t), t \geq 0\}$:

$$Y_k = X_k + \varepsilon_k$$

where $Y_k = Y(t_k)$, $X_k = X(t_k)$, $\varepsilon_k = \varepsilon(t_k)$ are respectively the measured degradation, actual degradation and measurement error (ME) at t_k .

- **Statistically independent ME:** $\varepsilon_k \sim N(0, \sigma_\varepsilon^2)$:

$$E[Y(t)] = \beta \Lambda(t)$$

$$\text{Var}[Y(t)] = \frac{\beta^3}{\eta} \Lambda(t) + \sigma_\varepsilon^2$$

$$\text{VMR}[Y(t)] = \frac{\beta^2}{\eta} + \frac{\sigma_\varepsilon^2}{\beta \Lambda(t)}$$


a perturbed IG process model $\{Y(t), t \geq 0\}$:

$$Y_k = X_k + \varepsilon_k$$

- Statistically dependent ME: $\varepsilon_k \sim N(0, \sigma_{\varepsilon_k}^2(x_k))$:

$$f_{\varepsilon_k|X_k}(z|x_k) = \frac{1}{\sqrt{2\pi}\sigma_{\varepsilon_k}(x_k)} \exp\left[-\frac{z^2}{2\sigma_{\varepsilon_k}^2(x_k)}\right]$$

- Reliability assessment:

$$\begin{aligned} F_T(t) &= P\{X(t) < D\} \\ &= \Phi\left[\sqrt{\frac{\eta\Lambda^2(t)}{D}}\left(\frac{D}{\beta\Lambda(t)} - 1\right)\right] + \exp\left\{\frac{2\eta\Lambda(t)}{\beta}\right\} \Phi\left[-\sqrt{\frac{\eta\Lambda^2(t)}{D}}\left(\frac{D}{\beta\Lambda(t)} + 1\right)\right] \end{aligned}$$

VMR for the perturbed IG process model:

$$VMR(Y_k) = \frac{\beta^2}{\eta} + \frac{\sqrt{\eta}}{\sqrt{2\pi}\beta} \int_0^{+\infty} \sigma_{\varepsilon_k}^2(x_k) x^{-\frac{3}{2}} e^{-\frac{\eta[x-\beta\Lambda(t_k)]^2}{2\beta^2 x}} dx$$

(1) On condition of X_k , Y_k follows a normal distribution:

$$f_{Y_k|X_k}(y|x_k) = f_{\varepsilon_k|X_k}(y - x_k|x_k)$$

(2) Conditional expectation and variance:

$$E[Y_k|X_k = x_k] = x_k, \text{Var}(Y_k|X_k = x_k) = \sigma_{\varepsilon_k}^2(x_k)$$

(3) Unconditional expectation and variance:

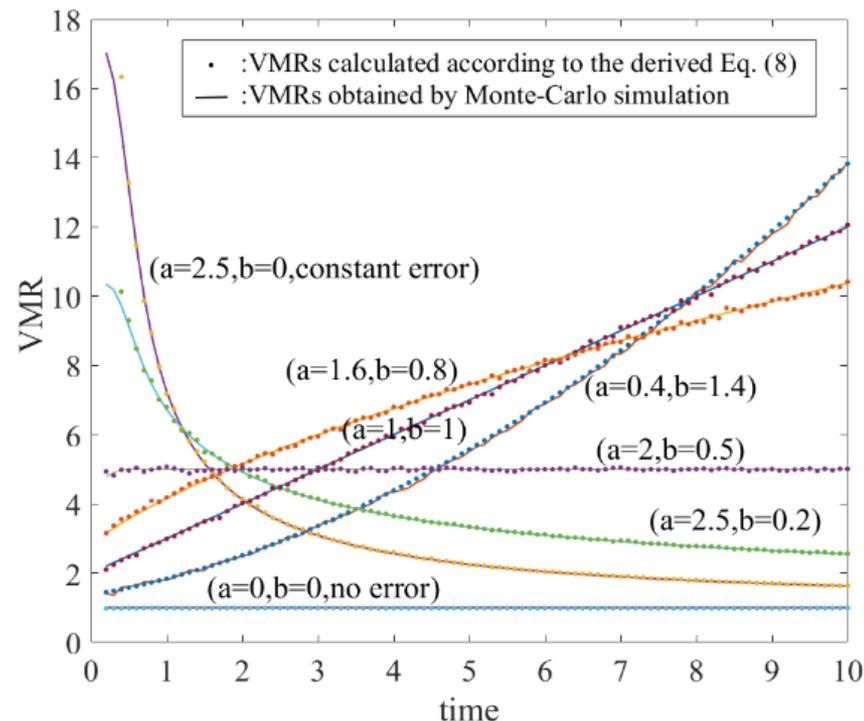
$$E(Y_k) = E_X[E_Y(Y_k|x_k)] = \beta\Lambda(t_k)$$

$$\text{Var}(Y_k) = E_X[\text{Var}(Y_k|x_k)] + \text{Var}_X[E(Y_k|x_k)]$$

VMR for the perturbed IG process model:

Assume a flexible power function: $\sigma_{\varepsilon_k}(x_k) = ax_k^b$, $a, b > 0$.

Depending on different values of a, b , the VMR of the proposed model can display various kinds of trends:



Parameter estimation:

The introduction of ME makes that the measured degradation increments are no longer independent.

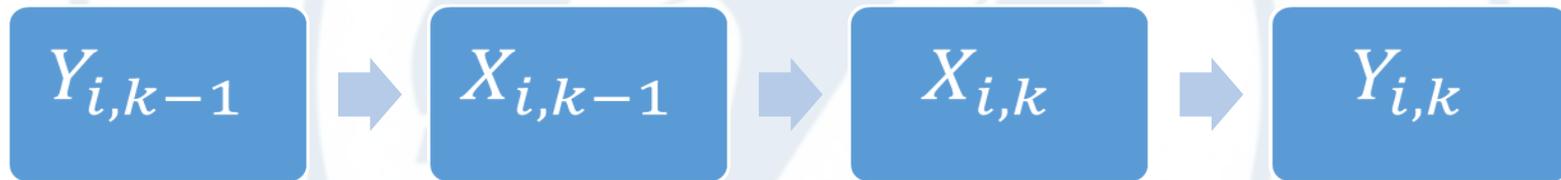
Based on the concept of conditional probability, the likelihood function can be expressed as:

$$L(y; \theta) = \prod_{i=1}^n f_{Y_{i,1}}(y_{i,1}) f_{Y_{i,2}|Y_{i,1}}(y_{i,2}|y_{i,1}) \cdots f_{Y_{i,m_i}|Y_{i,m_i-1}}(y_{i,m_i}|y_{i,m_i-1})$$

where $y_{i,k} = y(t_{i,k})$ is the measured degradation performance, and $f_{Y_{i,k}|Y_{i,k-1}}(y_{i,k}|y_{i,k-1})$ is the PDF of $y_{i,k}$ conditioned on $y_{i,k-1}$.

Parameter estimation:

The conditional PDF $f_{Y_{i,k}|Y_{i,k-1}}(y_{i,k}|y_{i,k-1})$ can be computed in the following **step-by-step way**.



$$(1) f_{X_{i,k-1}|Y_{i,k-1}}(v|y_{i,k-1}) = \frac{f_{Y_{i,k-1}|X_{i,k-1}}(y_{i,k-1}|v) \cdot f_{X_{i,k-1}}(v)}{\int_0^{+\infty} f_{Y_{i,k-1}|X_{i,k-1}}(y_{i,k-1}|u) f_{X_{i,k-1}}(u) du}$$

$$(2) f_{X_{i,k}|Y_{i,k-1}}(w|y_{i,k-1}) = \int_0^{+\infty} f_{X_{i,k}|X_{i,k-1}}(w|v) f_{X_{i,k-1}|Y_{i,k-1}}(v|y_{i,k-1}) dv$$

$$(3) f_{Y_{i,k}|Y_{i,k-1}}(y_{i,k}|y_{i,k-1}) = \int_0^{+\infty} f_{Y_{i,k}|X_{i,k}}(y_{i,k}|w) f_{X_{i,k}|Y_{i,k-1}}(w|y_{i,k-1}) dw$$



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PART THREE

Numerical experiments

- ① simulation study
- ② two case studies

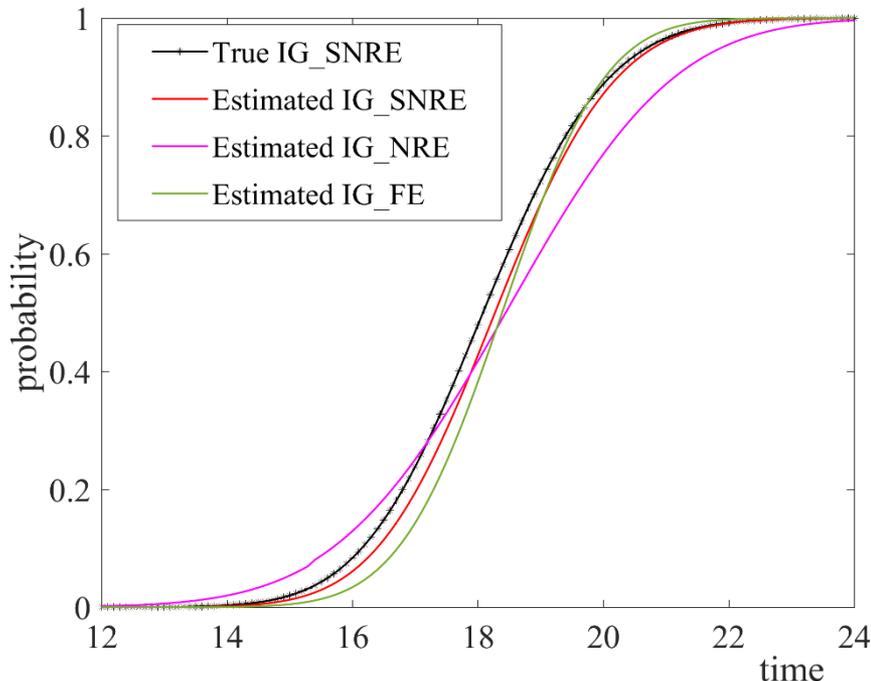
Performance of the parameter estimation methods:

- Power drift function: $\Lambda(t) = t^b$
- 1000 repetitions to calculate bias and standard deviations
- The MLEs can accurately estimate the model parameters
- The estimation accuracy increases with sample size

Sample size	$\mu = 2$	$\sigma = 0.2$	$\alpha = 5$	$\eta = 2$	$b = 1.2$
30	0.0747 (0.1441)	-0.0201 (0.0343)	0.0261 (0.2459)	0.0143 (0.2655)	0.0035 (0.0174)
60	0.0713 (0.1435)	-0.0149 (0.0271)	0.0205 (0.2430)	0.0119 (0.2620)	0.0032 (0.0161)
90	0.0460 (0.1397)	-0.0128 (0.0264)	0.0235 (0.2553)	0.0078 (0.2517)	0.0015 (0.0162)

Lifetime estimation accuracy with mis-specification:

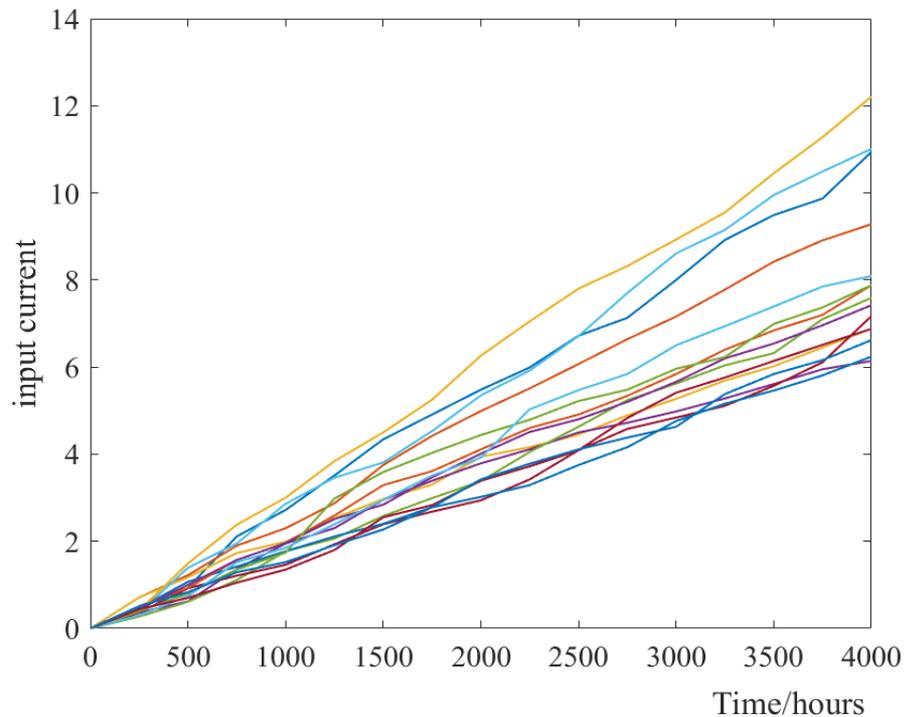
- ① Simulate degradation data under the proposed model
 - ② Estimate and compare three candidate models
- the true model can be selected with the lowest MSE



Candidate Model	MSE
IG_FE	1.91E-3
IG_NRE	3.62E-3
IG_SNRE	5.68E-04

GaAs laser device degradation experiment:

- Sample size: 15
- Inspection interval: 250 hours.
- Failure threshold level: 10A



Parameter estimation results – random effects:

A **linear drift function** is chosen based on experience.

Compared to models IG_FE and IG_NRE, the proposed EIG model with SN random effects has the smallest AIC, and therefore has the best degradation fitting performance.

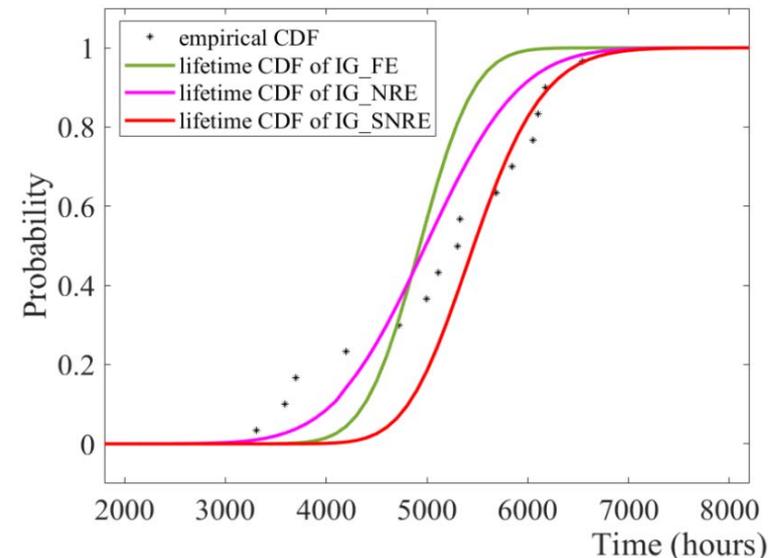
	η	μ	σ	α	L_{max}	AIC
IG_FE	5.43E-5	490.65	-	-	75.03	-146.06
IG_NRE	6.09E-5	498.59	61.30	-	75.23	-144.46
IG_SNRE	6.09E-5	500.26	61.41	-29.70	77.18	-146.36

Reliability assessment results – random effects :

- Present the **empirical CDF** of the 15 samples as dots.
- Plot the **lifetime CDFs** for the candidate models as lines.
- Calculate the **MSEs** of candidate models with the empirical CDF.

The proposed model **IG_SNRE** can most precisely estimate the lifetime distribution.

Candidate Model	MSE
IG_FE	5.21E-3
IG_NRE	2.22E-3
IG_SNRE	1.62E-3



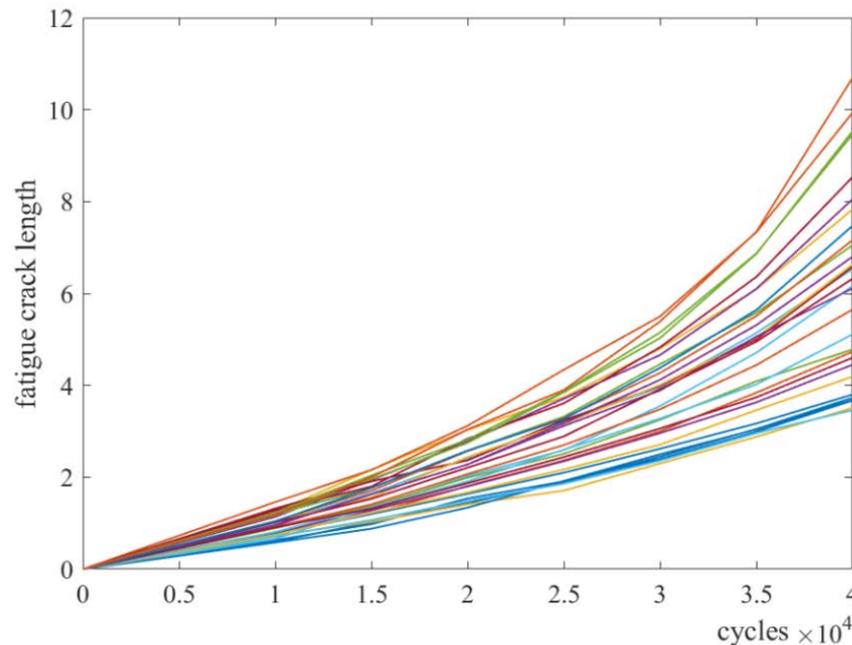
Parameter estimation results – measurement errors:

Compared to the existing models IG_0 and IG_SIME, the proposed model IG_SDME with statistically dependent measurement error has the smallest AIC, and therefore has the best degradation fitting performance.

	η	β	a	b	L_{max}	AIC
IG_0	5.43E-5	2.04E-3	-	-	75.03	-146.06
IG_SIME	5.44E-5	2.04E-3	9.00E-4	-	75.02	-144.04
IG_SDME	5.12E-5	2.04E-3	2.96E-3	0.9917	77.69	-147.38

Constant amplitude fatigue test:

- Sample size: 30
- Measurement interval: first after 10000 cycles and then every 5000 cycles.
- Failure threshold level: 15



Analysis of random effects:

An exponential drift function is chosen.

5 candidate distribution forms are compared for the inverse slopes of 30 specimens, among which the skew-normal distribution performs the best.

Distribution type	L	AIC
Normal	24.6104	-45.2208
Gamma	25.4566	-46.9132
Lognormal	24.3753	-44.7506
Weibull	25.5983	-47.1966
Skew-normal	26.8775	-47.755

Parameter estimation results:

The proposed model **IG_SNREME**, considering both skew-normal random effects and measurement errors, has the smallest AIC and best degradation fitting performance.

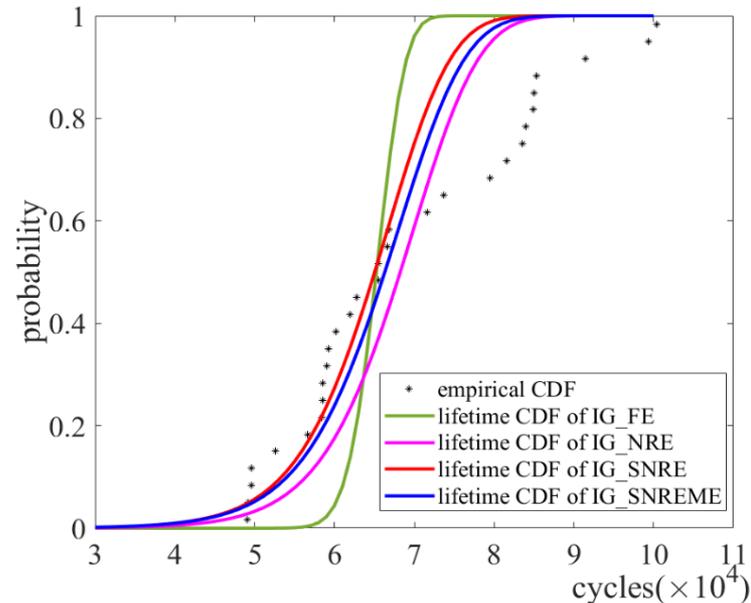
	η	μ	σ	α	γ	σ_ε	L_{max}	AIC
IG_FE	92.69	0.2915	-	-	0.2582		-41.49	88.99
IG_NRE	204.17	0.2829	0.066	-	0.2428		-37.01	82.03
IG_SNRE	136.73	0.3093	0.077	0.8252	0.2680		-33.70	77.40
IG_SNR EME	186.55	0.2805	0.070	0.8481	0.2509	2.54E-4	-32.63	77.26

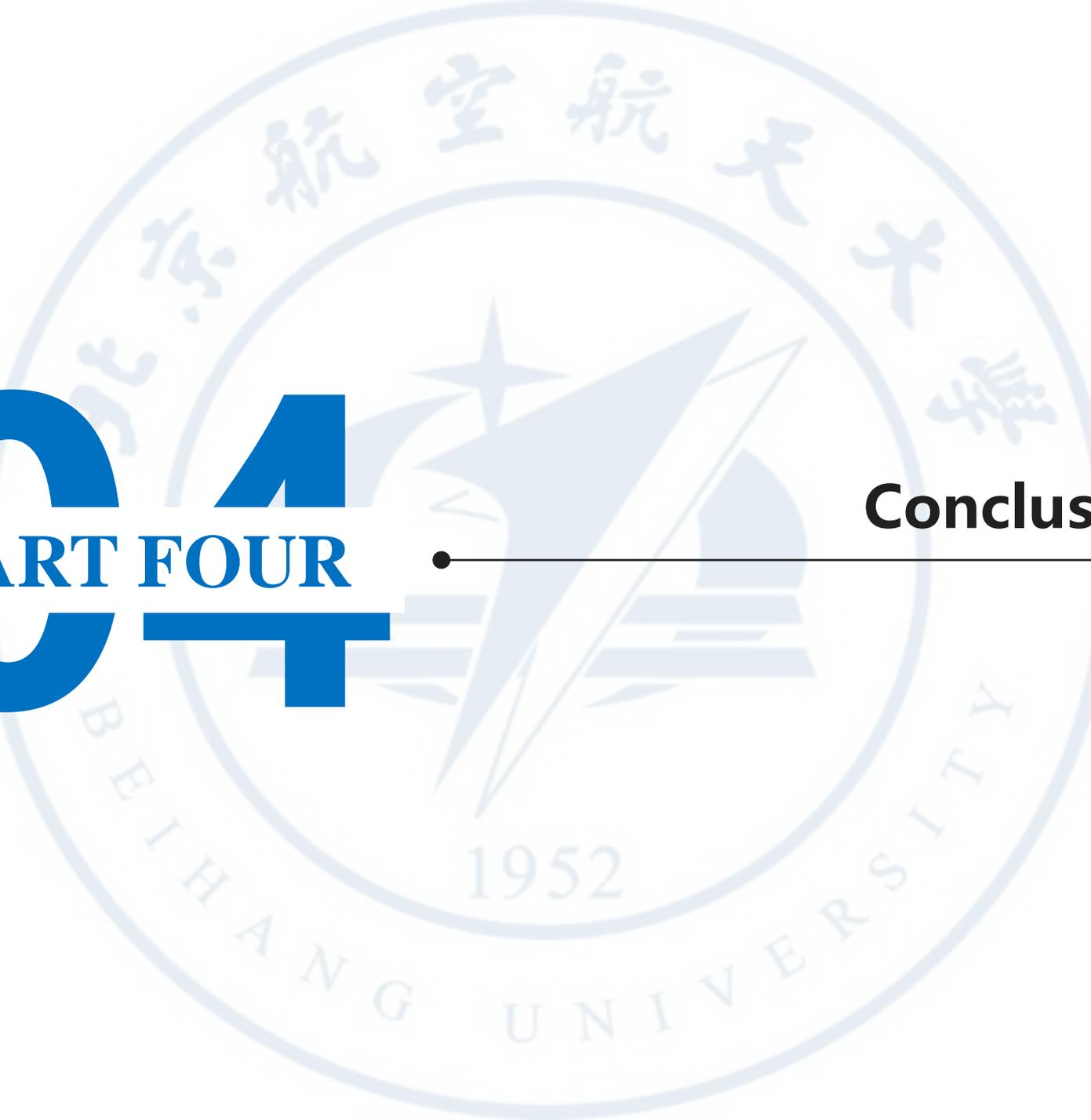
Reliability assessment results:

- Present the empirical CDF of the 30 specimens as dots.
- Plot the lifetime CDFs for the candidate models as dashes.
- Calculate the MSEs of candidate models with the empirical CDF.

The proposed model IG_SNREME can most precisely estimate the lifetime distribution.

Candidate Model	MSE
IG_FE	4.53E-3
IG_NRE	2.14 E-3
IG_SNRE	1.70 E-3
IG_SNREME	1.66 E-3





04
PART FOUR
04

Conclusion

- ✓ Extend the traditional IG process by incorporating **skew-normal random effects**;
- ✓ Analytically assess the reliability for the EIG process;
- ✓ Propose a perturbed IG process model with **statistically dependent measurement error**;
- ✓ Obtain the VMR of the perturbed IG process model;
- ✓ Verify the two degradation models by numerical experiments of **GaAs laser** and **fatigue crack growth**.

- ❑ **Combination** of both skew-normal random effects and statistically dependent measurement errors;
- ❑ **Degradation test planning** and **maintenance strategy optimization** for the extended and perturbed IG process;
- ❑ **Generalization** of the IG process to have time-varying VMR.



Thanks for listening!

Songhua Hao